Single point vibration measurement



INTRODUCTION

SmarAct's **PICO**SCALE is a contact-free displacement sensor with sub-atomic resolution based on a laser interferometer. The fast data processing allows for high bandwidth vibration measurements. In this application note, the vibrations of a small cantilever are analyzed.

The results show that the PICOSCALE can be used for single point vibration analysis. The low noise floor and high resolution allows to study mechanical properties of samples in fundamental RnD. At the same time, the high dynamic range allow to track macroscopic motions and vibrations, qualifying the system for industrial applications and process control at larger scales.

SETUP

The setup used for this application note is shown in Figure 1.

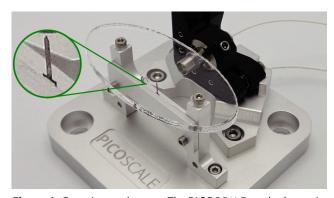


Figure 1. Experimental setup. The **PICO**SCALE probe beam is focused to a tungsten cantilever with a PS-SH-F01-10 sensor head.

A F01-10 sensor head (focusing sensor head with working distance 10 mm and spot size of about 30 μ m) is aligned to a cantilever. The cantilever is glued to a piezo stack to eventually excite vibration modes.

Even though many cantilevers are made from silion, which have low reflectivity at infrared wavelengths, the PICOSCALE can be used to measure the displacement. As the measurement beam is focused, this confocal configuration suppresses stray light from other surfaces and only a single surface is analyzed. (This smart concept is employed in the PICOSCALE Vibrometer, a turn-key solution for full modal analyses of of small samples.)

RESULTS

The recorded position data can directly be analyzed using the Fast-Fourier-Transform (FFT) functions of the **PICO**SCALE graphical user interface.

Thermal spectrum

First, the cantilever is not excited, but a very small peak around 2100 Hz appears, see Figure 2. This peak indicates a mechanical resonance, only excited by surrounding noise or thermal excitations.

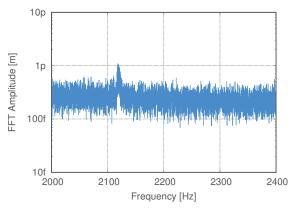


Figure 2. Thermal spectrum of the cantilever with a small peak around 2120 Hz.

Excitation

In the next step, the cantilever's eigenfrequency at 2119 Hz was excited with the piezo, which is driven by the **PICO**SCALE *Breakout Box*. The resonance peak becomes very pronounced.

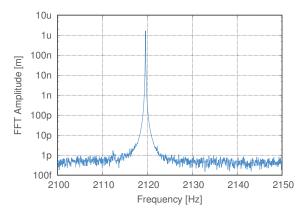


Figure 3. Resonance peak that is excited with the piezo stack below the cantilever.

Contact

Germany

SmarAct Metrology GmbH & Co. KG

Rohdenweg 4 D-26135 Oldenburg Germany

T: +49 (0) 441 - 800879-0 Email: metrology@smaract.com www.smaract.com

France

SmarAct GmbH

Schuette-Lanz-Strasse 9 26135 Oldenburg Germany

T: +49 441 - 800 879 956 Email: info-fr@smaract.com www.smaract.com

USA

SmarAct Inc.

2140 Shattuck Ave. Suite 302 Berkeley, CA 94704 United States of America

T: +1 415 - 766 9006 Email: info-us@smaract.com www.smaract.com

China

Dynasense Photonics

6 Taiping Street Xi Cheng District, Beijing, China

T: +86 10 - 835 038 53 Email: info@dyna-sense.com www.dyna-sense.com

Natsu Precision Tech

Room 515, Floor 5, Building 7, No.18 East Qinghe Anning Zhuang Road, Haidian District Beijing, China

T: +86 18 - 616 715 058 Email: chenye@nano-stage.com www.nano-stage.com

Shanghai Kingway Optech Co.Ltd

Room 1212, T1 Building Zhonggeng Global Creative Center Lane 166, Yuhong Road Minhang District Shanghai, China

Tel: +86 21 - 548 469 66 Email: sales@kingway-optech.com www.kingway-optech.com

Japan

Physix Technology Inc.

Ichikawa-Business-Plaza 4-2-5 Minami-yawata, Ichikawa-shi 272-0023 Chiba Japan

T/F: +81 47 - 370 86 00 Email: info-jp@smaract.com www.physix-tech.com

South Korea

SEUM Tronics

1109, 1, Gasan digital 1-ro Geumcheon-gu Seoul, 08594, Korea

T: +82 2 - 868 10 02 Email: info-kr@smaract.com www.seumtronics.com

Israel

Optics & Motion Ltd.

P.O.Box 6172 46150 Herzeliya Israel

T: +972 9 - 950 60 74 Email: info-il@smaract.com www.opticsmotion.com SmarAct Metrology GmbH & Co. KG develops sophisticated equipment to serve high accuracy positioning and metrology applications in research and industry within fields such as optics, semiconductors and life sciences. Our broad product portfolio – from miniaturized interferometers and optical encoders for displacement measurements to powerful electrical nanoprobers for the characterization of smallest semiconductor technology nodes – is completed by turnkey scanning microscopes which can be used in vacuum, cryogenic or other harsh environments.

We maintain the complete production in house for a high level of customization so that we can always provide you the optimal individual or OEM solution. We also offer feasibility studies, measurement services and comprehensive support to accompany you along your projects.

Headquarters

SmarAct GmbH

Schuette-Lanz-Strasse 9 26135 Oldenburg Germany

T: +49 441 - 800 879 0 Email: info-de@smaract.com www.smaract.com

USA

SmarAct Inc.

2140 Shattuck Ave. Suite 302 Berkeley, CA 94704 United States of America

T: +1 415 - 766 9006 Email: info-us@smaract.com www.smaract.com